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P2002,1010

CERTIFICATION OF MAILING OR TRANSMISSION

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SignatureApril 24, 2006  
DateIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/723,631 Confirmation No. 9710  
Applicant : Frank-Michael Kamm  
Filed : November 26, 2003  
Title : REFLECTION MASK FOR PROJECTING A STRUCTURE  
ONTO A SEMICONDUCTOR WAFER AND METHOD FOR  
PRODUCING THE MASK  
Group Art Unit : 1756  
Examiner : Stephen D. Rosasco  
Docket No. : P2002,1010  
Customer No. : 24131

R E S P O N S E

Mail Stop Amendment  
Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

S i r :

Responsive to the Office Action dated November 22, 2005,  
kindly consider the following:

Remarks/Arguments begin on page 2 of this paper.

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